## Notice of References Cited Application/Control No. 10/634,700 Examiner Jaric Loving Applicant(s)/Patent Under Reexamination KIM ET AL. Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-4,980,913 A	12-1990	Skret, Daniel L.	713/153
*	В	US-5,432,850 A	07-1995	Rothenberg, Michael	713/162
*	C	US-2003/0117998 A1	06-2003	Sala et al.	370/351
	D	US-			
	Е	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	7	US-			
	К	US-			·
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р				A	
	Q					
Ŀ	R					
	s					
	Т					

## NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	٠ د	
	<b>v</b>	
	w	
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.